

Pat-103 1
Appin. No
Inventor(s)
Title:
ENCLOSURE

PTO RECEIPT Attorney Docket: 061063-0306825

Amey Glenn J Perry/joyce hull

Appl. No. Date. November 13, 2003

Inventor(s). TAKA AKI SHIOTA ET AL

Title. SILICON WAFER AND MANUFACTURING METHOD THEREOF

☐ Preliminary Amendment ☒ Application Data Sheet
☐ Appendix ☒ Utility/Design/Provisional

17 No. of Pages Application (Spec + Claim(s) + Abstract)

☐ No. of Pages Separate Power of Attorney

☒ 10 No of Numbered Claims Only

☐ Declaration (___ of pages)

☐ Assignment ☐ Cover Sheet☐ No of Priority Documents

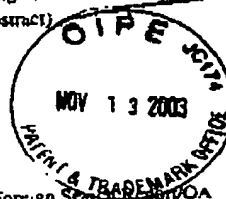
4 No of Sheets of Drawings (Fig(s) 1-5 B)

☒ IDS ☐ Appendix for Cited App(s) ☐ Foreign Search Report ☐ Nonpublication Request☒ PTO-1449 ☐ Cited Documents ☐ Nonpublication Request

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Other.

CURRENT DUE DATE November 20, 2003



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INFORMATION DISCLOSURE STATEMENT BY APPLICANT

(USE AS MANY SPACES AS POSSIBLE)

Sheet 1 of 1

Complete if Known

Application Number	
Filing Date	11/13/2003
First Named Inventor	TAKAAKI SHIOTA
Art Unit	
Examiner Name	
Attorney Docket Number	061063-0306825

U. S. PATENT DOCUMENTS

[illegible]

FOREIGN PATENT DOCUMENTS

Examiner Initials*	Cite No.	Foreign Patent Document		Publication Date MM-DD-YYYY	Name of Patentee or Applicant of Cited Document	Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear	T*
		Country Code*	Number* Kind Code* (if known)				
	A	WO	98/38675 A1	09-03-1998	FALSTER et al.		
	B	JP	2001-156074	06-08-2001	MUROI et al.		X

Examiner Signature	Date Considered
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